Comparison of Effective Medium Procedures for Optical Modeling of Laminar Structures

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Abstract

This study addresses the question, "How can the optical properties of matter in ultrathin amorphous nonmetallic films in multilayers best be determined from reflectance \( R \) and transmission \( T \) measurements?" A blue shift in the band gap of plasma CVD a-Si:H/a-SiNx:H multilayers was reported several years ago. It was suggested that the shift in the band gap, \( E_g \), relative to bulk a-Si:H as given by the Taup plot was due to quantum confinement effects. The purpose of this study is to evaluate the usefulness of various effective media theories (EMT) for determining the optical constants of materials in a multilayer and to explore to what extent a shift in band gap to higher energy may be an artifact of the method of optical analysis.

Incoherent approaches are the most common methods of determining band gap from \( R \) and \( T \). These do not require iteration to obtain optical constants from the optical data. The band gap determined by such methods was, however, generally 8% higher than the actual band gap when a suitable hypothetical case was investigated. Coherent effective media theory provides a noteworthy alternative to both incoherent EMT and fully coherent multilayer modeling, (which is accurate but is excessively complicated and poorly convergent). The accuracy of the band gap is at the limit, 2-3%, of what can be expected for graphical methods. A previously unappreciated source of optical artifacts was also identified. Dispersion, which is commonly ignored when \( E_g \) is determined graphically, is shown to distort, in certain cases, the anticipated straight line behavior of the \( \sqrt{aE} \) vs. \( E \) plot.

Introduction

The properties of materials in ultrathin films frequently differ from the same materials in thicker films and in bulk form. Optical properties and electrical transport of metallic and semiconductor films provide many examples of this. The changes have been related to film discontinuity, for example agglomeration, surface oxides, inclusion of residual gas, voids, and microstructural or surface morphological differences.

The purpose of this study is to investigate the suitability of various methods of determining optical constants of ultrathin (0.5 nm to 150 nm) amorphous germanium films in multilayer structures from reflectance and transmission measurements. Multilayers are useful for a variety of technological devices and basic science investigations. There are several advantages of such structures for basic science studies. The addition of layer upon layer facilitates the study of phenomena where interfaces are important, such as intermixing, diffusion and where the mass of a single thin film might be inadequate for accurate measurements such as in the determination of thermal conductivity.

In the present investigation the fact that in a multilayer the absorbance is a composite of the absorbances of many layers makes it possible to determine \( n \) and \( k \) of an ultrathin film germanium near the optical band gap. Furthermore, the effect of surface environment contamination is minimised.

Multilayers have proven to be objects worth studying in their own right. In single crystal epitaxy multilayers, so called superlattice structures, the existence of quantum size effects is now well established and a number of very interesting electronic and optoelectronic phenomenon have been studied. Since the advent of amorphous tetrahedral semiconductor alloys such as a-Si:H, which can possess noteworthy optoelectronic properties and a low density of states in the gap, multilayers containing amorphous materials have been prepared and characterized. Among the various properties reported, one of the most interesting is a blue shift of the apparent band gap of a-Si:H/a-SiNx:H multilayers.
A key property of crystalline superlattices which may be shared by their amorphous analogues is a shift to higher energy of the band gap of the material possessing the narrower band gap. In the case of crystalline multilayers, confinement of the carriers in an ultrathin, low band gap region sandwiched between wider band gap material has the quantum mechanical effect of increasing the optical band gap (a "blue" shift) of the narrow band material. The Kronig-Penny model is often used to explain the effect. Quantum confinement has also been used to explain the reported increase in optical gap of a-Si:H/a-SiN_x:H multilayers.

There are other possibilities, such as the potential of structural and compositional differences between ultrathin and thicker thin film material. Cross contamination between layers is also a possibility. The incorporation of nitrogen from the a-SiN_x deposit into the a-Si:H layers will produce a material with higher band gap. There is also evidence that there could be excess hydrogen at the interfaces of layers.

The formal parallels between amorphous and crystalline multilayers are not sufficient to establish quantum confinement as the source of the blue shift in amorphous multilayers. Phase coherence of the carrier wavefunctions over the dimensions of the well is often regarded as a requirement to see quantum size effects in multilayers. Amorphous materials lack long range order. The optical absorption properties of a-Si alloys differ from crystalline silicon near the band edge. Many of these differences are due to changes in transition probabilities and wavefunctions arising from the loss of the long range order of crystalline silicon. Can the carriers maintain sufficient phase information in such a disordered matrix for quantum size effects?

It is also possible that part or all of the blue shift is an artifact of optical analysis. In most studies, the band gap has been extracted from transmission data using one or another of incoherent effective medium approaches. Recently a few authors have addressed the validity of such approaches. The issue, however, is not closed. The effect on band gap determination due to the presence of the dispersion in the refractive index of the dielectric layer have not been properly addressed in the past. In this study it will be shown to be potentially quite important.

The determination of the structures and properties, particularly the optical properties, of materials in ultrathin layers in multilayers is a rather formidable undertaking which must be approached on several levels. A natural hierarchy is suggested: first, the development of optical modeling and analysis tools, specifically determination of the appropriate modeling and analysis techniques for computing the optical constants from measured data; second, development of preparation techniques and, structural characterization methods of ultrathin films; third, measurement of the optical constants of a series of samples to determine if the fundamental optical constants of materials vary as a function of thickness, and lastly, model development to explain any variations observed.

The efforts, in fact, have proceeded in parallel with ever increasing refinements. The study reported here focuses specifically on evaluating the various methods for determining the optical properties of ultrathin films and multilayers with an eye towards the identification and development of the appropriate optical analysis tools for ultrathin layers in multilayers.

Calculations and Effective Media Band Gaps of Synthetic Spectra

1. Computational Approach

The strategy adopted here was to calculate the reflectance (R) and transmittance (T) of a series of amorphous semiconductor/dielectric (a-Ge/a-SiN_x) multilayers using a standard coherent optical multilayer computation program. The choice of layers, their thicknesses, the number of periods and the optical constants of the materials used were made to emulate as closely as possible to actual multilayers to increase the relevance of the results to parallel experimental studies. The optical constants, over the required wavelength range, of the materials needed to generate the synthetic reflectance and transmittance were determined from individual ion beam sputtered a-SiN_x and a-Ge thin films.

The synthetic reflectance and transmittance were then analyzed by various coherent and incoherent effective medium theoretical approaches to extract the apparent band gap of the semiconductor in the multilayer. Since the actual band gap of the semiconductor was known, the accuracy of each method or approach could be evaluated by determining the apparent band gap for specific multilayer configurations.

2. Optical properties of a-Ge and a-SiN_x

In Fig. 1 we show a plot of \( \sqrt{\alpha E} \) vs. \( E \) for the two materials used in the multilayer model. The plot has many of the same features as the more fundamental plot of \( \sqrt{\alpha E^2} \) which was first introduced by Tauc. This form of the Tauc plot is the form commonly used by physicists in obtaining band gaps from thin film reflection and transmission data. The intercept at the \( E_x \) axis is defined as the optical band gap.

Figure 1 contains data for both a-Ge and a-SiN_x. The points plotted in Fig. 1 are calculated from a realistic parametric model of the optical properties of ion beam sputtered a-Ge and a-SiN_x.

The term "heterobases" can be applied to a-
Ge/a-SiNₓ multilayers. In contrast to homobasis multilayers like a-Si alloy/a-SiNₓ:H, in a-Ge/a-SiNₓ multilayers the network in the dielectric and semiconductor layers are based on different elements. The semiconductor layer is a-Ge, whereas the dielectric layer is based on silicon. The structural characterization of such multilayers is facilitated by the fact that the silicon and germanium containing species are deposited in separate, adjacent layers. Using Raman spectroscopy to determine the number of adjacent, bonded silicon-germanium atoms, it is relatively easy to measure the amount of intermixing between layers. This aids in determining the extent to which intermixing between layers might be the cause for blue shifts in multilayers when such a shift is observed. The preparation and structural characterization of these ion beam sputtered multilayers is discussed elsewhere.¹³

The band gap of a-SiNₓ depends on details of preparation. The a-SiNₓ dielectric produced by ion beam sputtering was found to be nitrogen deficient with the effect that the material is weakly absorbing above 1.8 eV. This is clear in Fig. 1. This produces absorption which adds to that of a-Ge. This absorption is, however, orders of magnitude less than the absorption of a-Ge even in the films with are mostly SiNₓ.

The realistic parametric model used in generating the synthetic spectra of the present work is rooted in the modern understanding of the optical properties of amorphous tetrahedral semiconductors. The absorbance, at moderate to high values of the absorbance, is described using the Tauc law; at low values of the absorbance an Urbach Tail is used. The dispersion in the index is modeled as a power series in \( \lambda^{-2} \), truncated after the \( \lambda^{-6} \) term.

Further details can be found in Ref. 14. Note, as anticipated, that the graphical intercept matches in both cases the band gap used in the model to the expected accuracy of the procedure. The measured reflectance and transmittance of ion beam sputtered a-Ge and a-SiNₓ had been modeled using this parametric model in a previous study.¹³ The parameters obtained were used in the current study. Thus the \( R \) and \( T \) of the theoretical multilayer calculated in the present study mimic the optical properties of real multilayers containing a-Ge and a-SiNₓ have important implications for the characterization of real multilayers discussed elsewhere.⁹

3. Computing theoretical reflectance and transmittance data

The \( R \) and \( T \) for a series of multilayers was computed. The multilayers consisted of 10 periods of a-Ge/a-SiNₓ on a borosilicate glass substrate. The layer against glass was amorphous germanium while a-SiNₓ was the layer facing out. The optical medium in front of the multilayer and behind the glass was assumed to have an index of 1.00; transmission re-

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![Fig. 1. Tauc Plot for values of a-Ge(curve a) and a-SiNₓ (curve b) used in calculating synthetic multilayer reflectance (R) and transmission (T). Data is drawn from Ref. 13, a study of ion beam sputtered a-Ge/a-SiNₓ multilayers. The match energy, where exponential tail is fitted on to the inner portion, is indicated with an arrow.](image)
flections between the substrates front and back surfaces were treated incoherently while the propagation of light in the multilayer was handled coherently.

For one set of traces the thicknesses of the a-Ge and a-SiN_x films in each period were equal at 40Å each. The effect of altering the a-Ge fraction while keeping the period thickness constant at 80Å was also investigated. In the most extreme case the Ge constituted only 10% of the stack.

It is appropriate to examine the assumptions made in deriving the commonly used form of the Tauc plot from the more fundamental \( \sqrt{\varepsilon_{2}}E^2 \). Use the definitions

\[
\varepsilon_2 = 2nk \\
k = \frac{\alpha\lambda}{4\pi}
\]

and

\[
E\lambda = 1.237\mu m \cdot eV
\]

It can be obtained that

\[
\sqrt{\varepsilon_{2}E^2} = \left(\frac{1.237\mu m \cdot eV}{2\pi}n\alpha E\right)^{1/2}
\]

Note that the simplification to \( \sqrt{\alpha E} \) involves the approximation that the refractive index, \( n \), is nondispersive, that is, that \( n \) is a constant. This is found to be a sufficiently good assumption for many amorphous materials. It is rare then for physicists to take the extra effort to compute \( n \) from the measured data and factor it in point by point in preparing Tauc plots to compute \( E_{\text{p}} \). Neglecting dispersion where it occurs can lead to difficulties in determining \( E_{\text{p}} \). Nevertheless, its effect is usually ignored.

4. The Tauc Band gap of an Effective media

When the optical thickness (ad) of each of the layers in a multilayer is comparable to a quarter of the wavelength of light strong interference can be expected. The optical thickness of the layers in multilayers for which a blue shift in \( E_{\text{p}} \) are observed, however, are more than a factor of twenty less than the wavelength of visible light (\( \lambda > 4000 \) Å). In such cases the electromagnetic field of the light varies slowly over one period of the multilayer. Thus interference effects arising from ultrathin layers are found to be small. Thus it appears proper to treat such materials as one layer composed of a single effective material possessing optical properties intermediate between a-Ge and a-SiN_x. Approaches for averaging the optical constant of composites are termed effective medium theories (EMT). These can be coherent or incoherent with respect to the effect of the film on the substrate and the optical constants can be obtained point by point or as parameters for some functional form.

In fact the reflectance and transmittance spectra of the multilayer of this study, real or simulated, resemble those of a single semiconductor film on a substrate. Since the dielectric is transparent at the energy band edge of the semiconductor it is relatively common for researchers to extract a band gap from the composite film and attribute it to the semiconductor without further qualification. It is the appropriateness of this assignment that is being investigated.

It can be shown that in the illumination of lamellar structures at normal incidence to the surface, effective medium approaches take a particularly simple form. The complex effective dielectric constant, \( \varepsilon_f \), is just the volume weighted average of \( \varepsilon \) for each of the layers.

Thus

\[
\varepsilon_f = V_{\text{Ge}}\varepsilon_{\text{Ge}} + (1 - V_{\text{Ge}})\varepsilon_{\text{SiN}}
\]

remembering that

\[
\varepsilon = \varepsilon_1 + i\varepsilon_2
\]

where

\[
\varepsilon_1 = n^2 - k^2
\]

and

\[
\varepsilon_2 = -2nk
\]

and, similarly,

\[
\varepsilon_f = \varepsilon_{1,f} + i\varepsilon_{2,f}
\]

where \( \varepsilon_f \) is the effective complex dielectric constant and \( \varepsilon_{1,f} \) and \( \varepsilon_{2,f} \) are the real and imaginary components respectively.

So

\[
\varepsilon_{1f} = -V_{\text{Ge}}\varepsilon_{1,\text{Ge}} + (1 - V_{\text{Ge}})\varepsilon_{1,\text{SiN}}.
\]

If

\[
k_{\text{SiN}} = 0
\]

\[
k_f = V_{\text{Ge}}\frac{n_\varepsilon}{n_f}k_{\text{Ge}}
\]

\[
\sqrt{\alpha_f E} = \sqrt{V_{\text{Ge}}n_{\varepsilon}\frac{n_\varepsilon}{n_f}\sqrt{\alpha_{\text{Ge}}E}}
\]

Thus, if \( \sqrt{\alpha_{\text{Ge}}E} \) obeys Tauc law then so will \( \sqrt{\alpha_f E} \) provided \( n_{\varepsilon} \) and \( n_f \) are constants or vary in such a way that \( n_{\varepsilon}/n_f \) remains a constant.

This argument thus provides the justification for computing the effective optical constants of the multilayer as though it were a single layer and assigning the Tauc band gap to a-Ge. The assumptions that
It can be seen that the apparent intercept is 1.06 eV in both cases. Thus the incoherent EMT approaches can produce an entirely artificial blue shift in the band gap. The effect is a relatively minor 7%, however. We have found that this offset is relatively constant as the thickness of the layers goes to zero. In contrast, for actual a-Si:H/a-SiNx:H multilayers the thinner the layers the more pronounced is the blue shift. Therefore an optical analysis blue shift can be separated from a quantum well blue shift.

The fact that incoherent optical modeling can produce a blue shift, albeit relatively small, provides impetus to do coherent optical modeling. The same coherent fitting program that was used to determine from $R$ and $T$ the optical constants of amorphous Ge and amorphous SiNx in the a-Ge/a-SiNx multilayer was used to compute the apparent $n$ and $k$ of the synthetic multilayer treating it as a single effective median thin film.

Figure 3, curve a, is a Tauc plot employing the apparent $\alpha$ of a 20Å/40Å multilayer where $n$ and $k$ were calculated coherently. In contrast with the a-Ge spectra (see Fig. 1) which yields, by construction, a straight line (above the Urbach tail) on the Tauc plot, the graph of $\sqrt{\alpha E}$ above the tail is not a straight line. The line curves upward at high energy. The effect is not significant when values just above the tail region are used. The apparent band gap is

![Graph](image-url)
about 1.01 eV, just 2% higher than the actual $E_g$. When the highest energy points are used in the extrapolation of the band gap, however, the apparent band gap is 1.12 eV, approximately 13% higher than the actual band gap.

The source of the discrepancy is the curvature of the graph. That this is due to dispersion is made evident in curve b (Fig. 3) which uses the synthetic $K$ and $T$ spectra of a 90% SiNx/10% a-Ge multilayer to calculate an EMT $\alpha$, and $n$. Here the curvature of $\sqrt{\alpha E}$ is sufficient to make it difficult to define what is the region above the tail and to throw the extrapolated band gap as high as 1.37 eV when high energy data is used. A key point is that if data in the 1.5 to 2.5 energy range is used, which, for a-Ge, is the practical range to choose, the estimated band gap is 1.1 eV, only 12% higher than the actual band gap. It is worth asking how such a nonlinear graph arises from a multilayer which contains as the most absorbing material a-Ge when the plot of $\sqrt{\alpha E}$ vs. $E$ itself is a straight line. Whereas SiNx is largely transparent in the region of interest it influences the apparent band gap of the composite through its index of refraction which distorts the $\sqrt{\alpha E}$ form of the Tauc plot.

The effect of dispersion need not be a serious complication for most quantum well studies. Multi-layers which are 90% dielectric (a-SiNx, for example) and only 10% semiconductor (a-Ge or a-Si:H) represent extreme cases. In most films where evidences of quantum confinement effects have been claimed, the relative partitioning was closer to 50:50. While dispersion in the index of the dielectric component even for 50:50 multilayers does have an influence on the apparent band gap which must not be ignored for quantitative comparisons, the effect is smaller than the shifts in band gap in many cases. It is, therefore, not possible to discount all of the blue shift observed to optical analysis effects.

On the other hand, optical analysis effects must not be ignored. While incoherent models might still be favored for qualitative work because the calculations require minimal computer time and no iterations, the extent to which incoherent models consistently missed the band gap is significant. Coherent modeling is required for accurate work, on the other hand, full coherent optical modeling of the multilayer taking into account all of the layers is not desirable either. Such an approach can yield the correct band gap, but is intolerably time consuming and computationally demanding. Convergence is frequently slow and false minima are a possibility. It appears that coherent effective medium optical modeling approach of the type shown is Fig. 3 are a viable alternative. The time taken in setting up the problem and abstracting band gaps is relatively modest even for desk top computers. False minima are generally not a problem. In addition, coherent EMT calculates band gaps which generally differ from the actual band gap by only a few percent even when dispersion is significant.

We have observed further that this error can be decreased even further by explicitly taking into account the effects due to index of refraction. This can be done by using the $E/\sqrt{\varepsilon}$ version of the Tauc law or forming the ratio $n_{Ge}/n_f$ at all energies. Since the values of $n_{Ge}(\lambda)$ are generally unknown for films in multilayers, in calculating the ratio the values of a-Ge from conventional thin films can be used.

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Fig. 3. Tauc Plot for values of $\alpha$ obtained with a coherent effective media approach for synthetic a-Ge/a-SiNx multilayers

a. 10 periods of 40Å/40Å a-Ge/a-SiNx on glass.
b. 10 periods of 4Å/36Å a-Ge/a-SiNx on glass.

The presence of a-SiNx increases the value of $\sqrt{\alpha E}$ at higher photon energies.
Summary

Using the measured optical constants of a-Ge and a-SiNx in multilayers we have generated synthetic \( R \) and \( T \) data for a-Ge/a-SiNx multilayers.

These synthetic traces were analyzed by a number of commonly used effective media theory (EMT) procedures to obtain the band gap of the multilayer. Of the various approaches for obtaining band gaps which were studied, coherent EMT is particularly noteworthy. Whereas both incoherent effective media approaches yield a band gap about 8% high, the coherent approach determined the band gap to within 2-3% of the actual value (1.02 versus 0.986 eV). The coherent EMT approach requires computer iteration but the procedure is compatible with desk top computers and is far less time consuming than a complete coherent model which dealt with each layer in the stalk.

Refractive index dispersion can have a large effect on the determination of the band gap in cases containing much less absorber than dielectrics. The importance of this effect has not been previously appreciated for such problems. Versions of the Tauc plot which explicitly account for dispersion \( \sqrt{E_2 E_1} \) should be employed when dispersion effects are large. It appears that artifacts in optical analysis can account for some, but not all, of the blue shift in \( E_g \) seen in amorphous multilayers. Nevertheless, data supporting a "blue shift" in a-Si:H multilayers could be reexamined in light of this study.

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